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SERIAL **18/537238**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

CH920010070US1017 Rec'd PCT/PTO 31 MAY 2007

APPLICANT:

Emmanuel Delamarche, et al.

(Use several sheets if necessary)

FILING DATE:

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REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINE R INITIALS		DOCUMENT NUMBER	ISSUED DATE	NAME	CLASS	SUBCLAS S	FILING DATE (IF APPRO.)
/ME/	A1	6,089,853	07-18-00	BIEBUYCK ET AL			
	A2						
	A3						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATIO N	
							YES	NO
/ME/	B1	0 075 605 A1	25-09-81	EUROPE				X
/ME/	B2	WO 99/56878	11-11-99	PCT				X
/ME/	B3	WO 01/63241 A2	30-08-01	PCT			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

/ME/	C1	George M. Whitesides, et al, "Soft Lithography in Biology And Biochemistry", Annu. Rev. Biomed. Eng. 2001 pgs 335-373.
/ME/	C2	Mark Schena, "Microarray Biochip Technology", Eaton Publishing 2000
/ME/	C3	Jason T. Smith, "Spreading Diagrams for the Optimization of Quill Pin Printed Microarray Density", Langmuir 2002, 18, pgs 6289-6293.
/ME/	C4	IBM Technical Disclosure Bulletin, reference RD n446 Article 165 Page 1046, "Autonomous Displacement of a Solution in a Microchannel by Another Solution".
/ME/	C5	Bin Zhao, et al, "Surface-Directed Liquid Flow Inside Microchannels", Science, Vol 291, 9 February 2001, pgs 1023-1026.

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/Maria Ewald/

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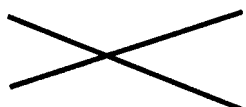
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	Filing Date		2005-05-31	
	First Named Inventor	Emmanuel Delamarche		
	Art Unit	1722		
	Examiner Name			
	Attorney Docket Number	CH920010070US1		

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STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10537238
Filing Date	2005-05-31
First Named Inventor	Emmanuel Delamarche
Art Unit	1722
Examiner Name	
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